Search Notes

Application/Control No.	Applica Reexam
10/762 453	CHANG

Examiner

David E. Martinez

Applicant(s)/Patent under Reexamination CHANG, AN-SHENG Art Unit

2181

SEARCHED				
Class	Subclass	Date	Examiner	
710	15,17,36,5 8,59	2/17/2006	DM	
714	1,2,14	2/17/2006	DM	
714	47,48	2/17/2006	DM	
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
East see attached	2/17/2006	DM	
Inventor Search eDan	2/17/2006	DM	
Databases: US Patents, US PGPUBS, USOCR, EPO, Derwent, IBM_TDB.	2/17/2006	DM	
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